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In re application of

TOMOHIRO OKUMURA ET AL :

Serial No. 09/918,823 :

Filed: August 1, 2001 :

Title: Plasma processing method and apparatus theeof

Attn: Office of Initial Patent

Examination Customer Service

Center

REQUEST FOR CORRECTED FILING RECEIPT

Assistant Commissioner for Patents, Washington, D. C.

Sir:

Enclosed herewith is a copy of the Official Filing Receipt for the above-identified application marked in red indicating corrections to be made thereto.

Accordingly, it is requested that the PTO issue a Corrected Filing Receipt reflecting these corrections.

Respectfully submitted,

TOMOHIRO OKUMURA ET AL

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/eak
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June 17, 2002



United States Patent and Trademark Office

COMMISSIONER FOR PATENTS UNITED STATES PATENT AND TRADEMARK OFFICE WASHINGTON, D.C. 20231 www.uspto.gov

APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY.DOCKET.NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/918,823	08/01/2001	2817	1280	2001_1089A	7	40	4

CONFIRMATION NO. 4423

UPDATED FILING RECEIPT

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000513 WENDEROTH, LIND & PONACK, L.L.P. 2033 K STREET N. W. SUITE 800 **WASHINGTON, DC 20006-1021**

Date Mailed: 11/26/2001

ECHNOLOGY CENTER 2800

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Domestic Priority data as claimed by applicant

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Early Publication Request: No

Title

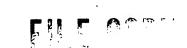
Plasma processing method and apparatus thereof

Preliminary Class

315



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Bib Data Sheet

CONFIRMATION NO. 4423

SERIAL NUMBE 09/918,823	FILING DATE 08/01/2001 RULE	CLASS 315	GROUP AR 2821		ATTORNEY DOCKET NO. 2001_1089A		
Yukihiro Ma Izuru Matsu ** CONTINUING E ** FOREIGN APPI JAPAN 200	kumura, Kadoma-shi, JAP egawa, Ibaraki-shi, JAPAN da, Ibaraki-shi, JAPAN; DATA ***********************************	N; ***					
Foreign Priority claimed 35 USC 119 (a-d) condit met Verified and Acknowledged ADDRESS 000513	tions ves o Met at	state or country JAPAN	SHEETS DRAWING 7	TOTA CLAIN 40	MS CLA	IMS	
TITLE Plasma processing	g method and apparatus th	nereof					
RECEIVED	FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following:			☐ All Fees ☐ 1.16 Fees (Filing) ☐ 1.17 Fees (Processing Ext. of time) ☐ 1.18 Fees (Issue) ☐ Other ☐ Credit			